

<b>Notice of References Cited</b>	Application/Control No. 10/756,424		Applicant(s)/Patent Under Reexamination YAMAKADO ET AL.	
	Examiner John C. Hong		Art Unit 3726	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
X	A	US-6,529,788	03-2003	Tani et al.	700/97
X	B	US-2004/0210334	10-2004	Tateishi et al.	700/106
X	C	US-2004/0215360	10-2004	Yamakado et al.	700/095
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N					
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**NON-PATENT DOCUMENTS**

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